

Notice of References Cited	Application/Control No. 10/673,909	Applicant(s)/Patent Under Reexamination HECKMEIER ET AL.	
	Examiner Shean C. Wu	Art Unit 1756	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	U	English translation by computer for JP 10-251186, http://www4.ipdl.ncipi.go.jp/Tokujitu/PAJdetail.ipdl?N0000=60&N0120=01&N2001=2&N3001=H10-251186
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